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Amend A
D. Smallis-Logan
67-03
Docket No. 740819-466

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DEC 30 2002

In re Patent Application of:)

Takumi MIKAWA et al.)

Serial No. 09/734,176)

Filed: December 12, 2000)

For: SEMICONDUCTOR DEVICE AND METHOD)
FOR FABRICATING THE SAME (TO BE
AMENDED)

Group Art Unit: 2811

Examiner: Steven Ho Yin LOKE

CERTIFICATE OF MAILING

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AMENDMENT

Commissioner for Patents
Washington, D.C. 20231

Sir:

In response to the Office Action mailed August 14, 2002, the due date for which having
been extended one (1) month to Saturday December 14, 2002, please amend the above identified
application as follows.

IN THE TITLE:

Please replace the title of the invention with the following:

--SEMICONDUCTOR DEVICE HAVING A FERROELECTRIC CAPACITIVE FILM--

IN THE CLAIMS:

Please cancel claim 2 without prejudice or disclaimer to the subject matter disclosed
therein.

Please amend claim 1 as follows:

1. (Amended) A semiconductor device comprising:

a lower electrode formed on a substrate;

a capacitive insulating film formed out of a ferroelectric film on the lower electrode;